

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|--------------|---|------------|--------------------|
| Applicant:   | Kisakibaru  | Art Unit:  | 2823               |
| App. No.:    | 10/537,133  | Examiner:  | William D. Coleman |
| Filing Date: | June 2, 2005  | Conf. No.: | 8488               |
| For:         | Air-curtain Forming Apparatus for Wafer Hermetic Container in Semiconductor-Fabrication Equipment of Minienvironment System |            |                    |

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE**

Dear Sir:

In response to the Notice of Allowance and Notice of Allowability dated April 23, 2008, Applicant submits herewith the following comments on the statement of reasons for allowance.

The Examiner states that the prior art does not anticipate nor render obvious an air-curtain having an injection slit and a guide slit with cylindrical shaped filters such that air supplied to an air supply tube passes through the injection slit and passes through the guide slit. However, the injection slit, guide slit, and cylindrically shaped filters are not all included in independent claims 4 and 7. For example, neither claim 4 nor claim 7 includes a guide slit.

Applicant appreciates the Examiner allowing all the pending claims.

Respectfully submitted,

DATE: July 22, 2008

/Kathryn E. Noll, #48,811/  
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